

**Search Notes**

Application/Control No.

10/783,703

Examiner

LAM T. MAI

Applicant(s)/Patent under  
Reexamination

LIN, CHIH-I

Art Unit

2819

**SEARCHED**

Class	Subclass	Date	Examiner
<i>L</i> 330	51 296 285 289 297 133 267 261	6/23/2005	LM

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
<i>Q</i>  Consulted with primary Mottala from class 330	6/23/2005	LM
<i>J</i>  Text Search	6/23/2005	LM